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PATENT  
Attorney Docket No. 14912.777

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Stephen E. Savas

Application No.: 09/692,255

Filed: 10/19/2000

For: Systems and Methods for Photoresist Strip  
And Residue Treatment in Integrated  
Circuit Manufacturing

Group Art Unit: 1746

Examiner: Alexander Markoff

Mail Stop Fee Amendment  
Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

**RESPONSE TO OFFICE ACTION**

**Introductory Comments:**

Applicants submit this Amendment in response to the Office Action mailed on December 4, 2003. Reconsideration of the above referenced application is respectfully requested in view of the following amendments and remarks.